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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/647,475	08/26/2003	Lim Su Lee	8733.311.10-US	2307
	7590	EXAMINER		
1900 K STREET, NW			MARKOFF, ALEXANDER	
WASHINGTON, DC 20006			ART UNIT	PAPER NUMBER
			1792	
			MAIL DATE	DELIVERY MODE
			05/28/2008	PAPER

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

	Application No.	Applicant(s)
	10/647,475	LEE, LIM SU
Office Action Summary	Examiner	Art Unit
	Alexander Markoff	1792
The MAILING DATE of this communication ap Period for Reply	pears on the cover sheet with the o	correspondence address
A SHORTENED STATUTORY PERIOD FOR REPL WHICHEVER IS LONGER, FROM THE MAILING D. - Extensions of time may be available under the provisions of 37 CFR 1. after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period Failure to reply within the set or extended period for reply will, by statut Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUNICATION 136(a). In no event, however, may a reply be tir will apply and will expire SIX (6) MONTHS from e, cause the application to become ABANDONE	N. nely filed the mailing date of this communication. D (35 U.S.C. § 133).
Status		
Responsive to communication(s) filed on 11 A This action is FINAL . 2b) ☑ This 3) ☐ Since this application is in condition for allowed closed in accordance with the practice under	s action is non-final. ance except for formal matters, pro	
Disposition of Claims		
4)	awn from consideration. is/are rejected.	
Application Papers		
9) The specification is objected to by the Examina 10) The drawing(s) filed on is/are: a) accomposed and applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the E	cepted or b) objected to by the drawing(s) be held in abeyance. Section is required if the drawing(s) is ob	e 37 CFR 1.85(a). jected to. See 37 CFR 1.121(d).
Priority under 35 U.S.C. § 119		
12) ☐ Acknowledgment is made of a claim for foreign a) ☐ All b) ☐ Some * c) ☐ None of: 1. ☐ Certified copies of the priority document 2. ☐ Certified copies of the priority document 3. ☐ Copies of the certified copies of the priority document application from the International Bureat* * See the attached detailed Office action for a list	nts have been received. Its have been received in Applicat Pority documents have been receive Bu (PCT Rule 17.2(a)).	ion No ed in this National Stage
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date	4) Interview Summary Paper No(s)/Mail D 5) Notice of Informal F 6) Other:	ate

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DETAILED ACTION

Continued Examination Under 37 CFR 1.114

1. A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on 3/11/2008 has been entered.

Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. The factual inquiries set forth in *Graham* v. *John Deere Co.*, 383 U.S. 1, 148 USPQ 459 (1966), that are applied for establishing a background for determining obviousness under 35 U.S.C. 103(a) are summarized as follows:
 - 1. Determining the scope and contents of the prior art.
 - 2. Ascertaining the differences between the prior art and the claims at issue.
 - 3. Resolving the level of ordinary skill in the pertinent art.
 - 4. Considering objective evidence present in the application indicating obviousness or nonobviousness.

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3. Claims 13, 16, 18, 23-25, 28-30 and 32-37 are rejected under 35 U.S.C. 103(a) as being unpatentable over Moinpour et al (US Patent No 5,901,399) in view of Fishkin et al (US Patent No 6,202,658) and Hashimoto et al (US Patent No 6,261,378).

Moinpour et al and Fishkin et al both teach cleaning substrates with brushes and sprays. Both documents are concern about cleaning side surfaces of the substrates during cleaning of the main surfaces. Both documents teach brushing of the main surfaces and spraying the side surfaces. Moinpour et al teach the use of cylindrical brushes and a liquid jet to clean the side surfaces. See at least Figures 2c, 3, 6 and 7 and the related description. The document does not specify whether or not the liquid jet is energized. Fishkin et al teach the use of ultrasonic liquid jet to clean the side surfaces. Having the combined teachings of the cited documents it would have been obvious to an ordinary artisan at the time the invention was made to use ultrasonic spray in the method of Moinpour et al to further enhance disclosed cleaning because the documents teach the action of brushes and ultrasonics to solve the same problem. An ordinary artisan would have been reasonably expected that the use of combined action would improve the side cleaning results.

Moinpour et al and Fishkin et al do not specifically recite application of their methods to LCD substrates. Both of the documents are mainly directed to cleaning semiconductor wafers. Fishkin et al, however, teach that the method can be applied to glass substrates.

Hashimoto et al teach that the same method of cleaning are conventionally applied to semiconductor wafers and glass substrates, such LCD glass substrates.

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Having combined teachings of Moinpour et al, Fishkin et al and Hashimoto et al it would have been obvious to an ordinary artisan at the time the invention was made to apply a modified method of Moinpour et al to LCD glass substrates with reasonable expectation of success in order to have the substrates cleaned.

As to the limitation requiring moving of the substrate in a linear direction and the brushes being parallel to the referenced direction: it is noted that Moinpour et al show that in a scrubber the substrate is not only rotated, but also is moving through the scrubber in a linear direction. See at least Figure 3 the related description. It would have been obvious to an ordinary artisan at the time the invention was made that the brushes shown on Figures 2c, 6, and 7 should be parallel to the direction of the movement at least at some time to enable the movement.

As to the limitation requiring cleaning of two side surfaces: It would have been obvious to an ordinary artisan at the time the invention was made that all surfaces of the LCD substrate should be cleaned. It would have been obvious to an ordinary artisan at the time the invention was made to provide and use an additional brush and an additional spraying device in the modified method of Moinpour et al in order to clean opposing surfaces of the LCD substrate in a single move in order to enhance cleaning. It is noted that, it has been held that mere duplication of the essential working parts of a device involves only routine skill in the art. St. Regis Paper Co. v. Bemis Co., 193 USPQ 8.

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Response to Arguments

4. Applicant's arguments filed 3/11/08 have been fully considered but they are not persuasive.

The applicants amended the claims and allege that the applied prior art does not teach or suggest cleaning and brushing the substrate simultaneously, while the substrate is moving continuously in a linear direction. The applicants have not provided analysis of the prior art to support their allegation.

The examiner disagrees with the applicants:

In contrast to the applicants' not supported statement, Moinpour et al teach cleaning and brushing while the substrate is continuously moving in a linear direction. See at least Figure 3 and description at column 4, lines 12-28.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Alexander Markoff whose telephone number is 571-272-1304. The examiner can normally be reached on Monday-Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Michael Barr can be reached on 571-272-1414. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Alexander Markoff Primary Examiner Art Unit 1792

AM

/Alexander Markoff/ Primary Examiner, Art Unit 1792